

Substitute for Form 1449/PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Application Number	10/763,779
		Filing Date	January 22, 2004
		First Named Inventor:	Qing Ma et al.
		Art Unit	2834
		Examiner Name	Thomas M. Dougherty
Sheet 1 of 1	Attorney Docket Number	42P10077D2	
NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
tmd	1.	Application No. 09/738,118, Filing date 12/15/2000, Qing Ma et al., "A PROCESS OF MAKING A MICRO-ELECTROMECHANICAL STRUCTURE RESONATOR WITH FREQUENCY ADJUSTMENT," Office Action mailed 06/15/2004. (42P10077)	
tmd	2.	Application No. 09/738,118, Filing date 12/15/2000, Qing Ma et al., "A PROCESS OF MAKING A MICRO-ELECTROMECHANICAL STRUCTURE RESONATOR WITH FREQUENCY ADJUSTMENT," Office Action mailed 12/17/2004. (42P10077)	
tmd	3.	Application No. 09/738,118, Filing date 12/15/2000, Qing Ma et al., "A PROCESS OF MAKING A MICRO-ELECTROMECHANICAL STRUCTURE RESONATOR WITH FREQUENCY ADJUSTMENT," Office Action mailed 11/30/2005. (42P10077)	
tmd	4.	Application No. 09/738,118, Filing date 12/15/2000, Qing Ma et al., "A PROCESS OF MAKING A MICRO-ELECTROMECHANICAL STRUCTURE RESONATOR WITH FREQUENCY ADJUSTMENT," Office Action mailed 06/01/2006. (42P10077)	
tmd	5.	Application No. 09/738,118, Filing date 12/15/2000, Qing Ma et al., "A PROCESS OF MAKING A MICRO-ELECTROMECHANICAL STRUCTURE RESONATOR WITH FREQUENCY ADJUSTMENT," Office Action mailed 10/06/2006. (42P10077)	
tmd	6.	Application No. 10/386,062, Filing date 03/10/2003, Qing Ma et al., "MICRO-ELECTROMECHANICAL STRUCTURE RESONATOR FREQUENCY ADJUSTMENT USING RADIANT ENERGY TRIMMING AND LASER/FOCUSED ION BEAM ASSISTED DEPOSITION," Office Action mailed 09/15/2003. (42P10077D)	
tmd	7.	Application No. 10/386,062, Filing date 03/10/2003, Qing Ma et al., "MICRO-ELECTROMECHANICAL STRUCTURE RESONATOR FREQUENCY ADJUSTMENT USING RADIANT ENERGY TRIMMING AND LASER/FOCUSED ION BEAM ASSISTED DEPOSITION," Office Action mailed 12/04/2003. (42P10077D)	
tmd	8.	Application No. 10/804,897, Filing date 03/19/2004, Qing Ma et al., "PROCESS FOR TUNING AN OSCILLATOR," Office Action mailed 12/13/2005. (42P10077D3)	
tmd	9.	Application No. 10/804,897, Filing date 03/19/2004, Qing Ma et al., "PROCESS FOR TUNING AN OSCILLATOR," Office Action mailed 10/05/2006. (42P10077D3)	

Examiner Signature	Thomas M. Dougherty	Date Considered	6-1-07
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*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²Applicant is to place a check mark here if English Translation is attached. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SENT FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450. If you need assistance in completing the form, call 1-800-PTO-8199 (1-800-786-9199) and select option 2.